IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: SUN-HEE KIM, ET AL.

FOR: METHOD OF TREATING SURFACE OF SUBSTRATE USED IN BIOLOGICAL REACTION SYSTEM

PRELIMINARY AMENDMENT

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Prior to the Examiner acting in the above-referenced application, please preliminary amend the above-identified application as follows.